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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MARK B. FUSELIER
DERICK J. WRISTERS
ANDY C. WEI

Examiner: Donghee Kang

Group Art Unit: 2811

Serial No.: 10/821,230

Att'y Docket: 2000.092182/TT5101D

Filed: April 8, 2004

Customer No.: 23720

For: SEMICONDUCTOR DEVICE FORMED
OVER A MULTIPLE THICKNESS
BURIED OXIDE LAYER, AND
METHODS OF MAKING SAME

RESPONSE TO FINAL OFFICE ACTION DATED JUNE 6, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING
37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

July 25, 2005

Date

Mary Paul
Signature

This paper is submitted in response to the Final Office Action dated June 6, 2005, for which the three-month date for response is September 6.

It is believed that no fee is due; however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason relating to this document, the Director is authorized to deduct said fees from Advanced Micro Devices, Inc. Deposit Account No. 01-0365/TT5077D.¹

Reconsideration of the application in view of the following amendments and remarks is respectfully requested.

¹ In the event the monies in that account are insufficient, the Assistant Commissioner is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.092182.